

Docket No.: 070759-0043

PATENT

Reply Under 37 CFR 1.116 – Expedited Procedure – Technology Center 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Yasuhiro WATANABE, et al.	:	Confirmation Number: 4618
	:	
Application No.: 10/575,680	:	Group Art Unit: 2828
	:	
Filed: April 13, 2006	:	Examiner: ZANG, Yuanda
	:	
For: TWO-BEAM SEMICONDUCTOR LASER APPARATUS	:	

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendment and remarks are submitted in response to the Office Action mailed July 17, 2008.